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1/28/23
NIT-288

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

N. KOFUJI et al

Serial No. 09/920,834

Group Art Unit: 1765

Filed: August 3, 2001

Examiner: Kin Chan

For: METHOD AND APPARATUS FOR FABRICATING
SEMICONDUCTOR DEVICES

RESPONSE TO RESTRICTION REQUIREMENT

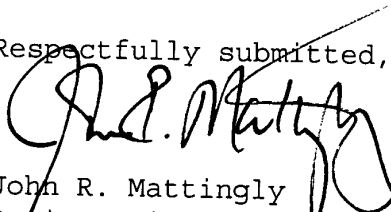
Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Restriction Requirement mailed January 16, 2003, Applicants elect to prosecute the invention defined by the Examiner as claims 1-6 and 8, drawn to a method, classified in class 438, subclass 692. This election is made without traverse.

The Commissioner is hereby authorized to charge any payment due to deposit account no. 50-1417.

Respectfully submitted,


John R. Mattingly
Registration No. 30,293
Attorney for Applicants

MATTINGLY, STANGER & MALUR
1800 Diagonal Road, Suite 370
Alexandria, Virginia 22301
(703) 684-1120
Date: January 24, 2003

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